



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818  
Examiner: David Nhu

In re PATENT APPLICATION of

Applicant : Takashi NAKAMURA et al. )  
Appl. No. : 09/856,818 )  
Filed : May 25, 2001 ) **AMENDMENT**  
For : METHOD OF FORMING SOLID OF A )  
FERRO OR HIGH DIELECTRIC )  
MATERIAL AND METHOD OF )  
MANUFACTURING SEMICONDUCTOR )  
DEVICE EMPLOYING THE SAME )  
Atty. Dkt. : AI 265NP )

August 27, 2003

RECEIVED  
SEP - 3 2003  
TECHNOLOGY CENTER 2800

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action April 10, 2003, the due date of which has been extended by a Petition for a two-month Extension of Time filed herewith, to expire on September 10, 2003, please amend the above-identified application as follows:

Fee Enclosed: \$ 10.00  
Please charge any further  
fee to our Deposit Account  
No. 18-0002